

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: **Junichi KON, et al.**

Serial Number: **Not Yet Assigned**

Filed: **July 8, 2003**

For: **CHEMICALLY AMPLIFIED RESIST MATERIAL AND PATTERNING METHOD
USING SAME**

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

July 8, 2003

Sir:

In compliance with 37 CFR 1.56, Applicants call to the attention of the Patent and Trademark

Office the reference listed on the attached PTO-1449.

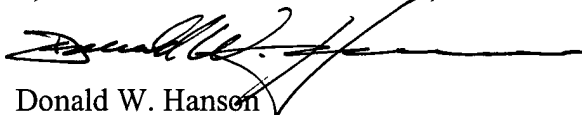
A copy of the reference is enclosed herewith.

In the event there are any fees due in connection with the filing of this paper, please charge

Deposit Account No. 01-2340.

Respectfully submitted,

ARMSTRONG, WESTERMAN & HATTORI, LLP



Donald W. Hansen
Attorney for Applicants
Reg. No. 27,133

DWH/jaz
Atty. Docket No. **030820**
Suite 1000
1725 K Street, N.W.
Washington, D.C. 20006
(202) 659-2930



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PATENT TRADEMARK OFFICE

Enclosures: PTO-1449; References (1)

INFORMATION DISCLOSURE STATEMENT PTO-1449	Atty. Docket No. 030820	Serial No. New Application
	Applicant(s): Junichi KON, et al.	
	Filing Date: July 8, 2003	Group Art Unit: Not Yet Assigned

U.S. PATENT DOCUMENTS

Examiner Initial	Document No.	Name	Date	Class	Subclass	Filing Date (If appropriate)
_____	AA					
_____	AB					
_____	AC					
_____	AD					

FOREIGN PATENT DOCUMENTS

Document No.	Date	Country	Translation (Yes or No)		
_____	AE	11-352702	12/24/99	Japan	Yes-Abstract
_____	AF				
_____	AG				
_____	AH				
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OTHER DOCUMENTS

_____	AJ			
_____	AK			
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